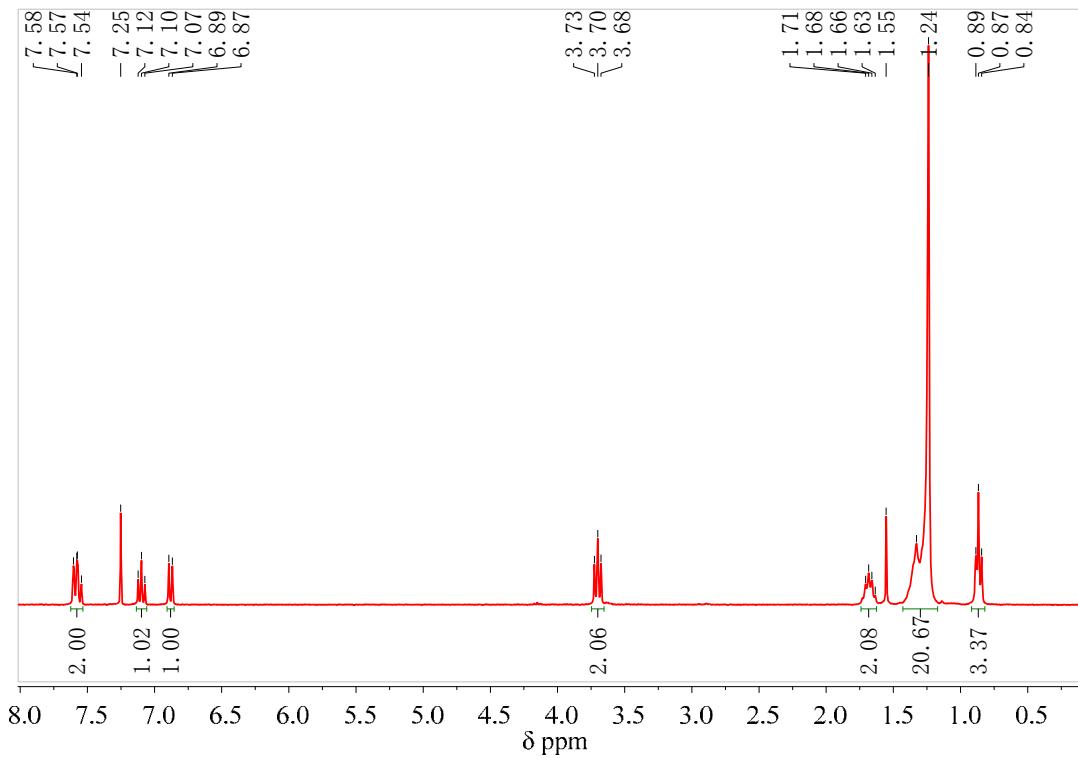


**Supporting Information for**

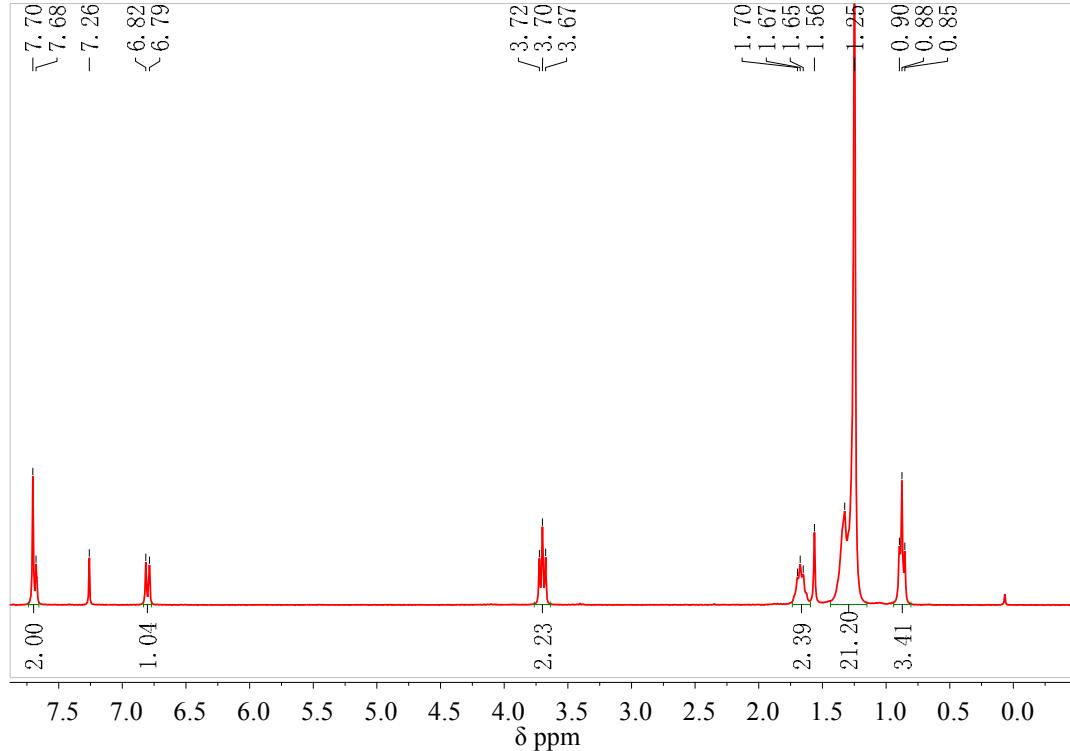
**Thiophene-S,S-dioxidized indophenines as high performance n-type organic  
semiconductors for thin film transistors**

*Yunfeng Deng, Bin Sun, Jesse Quinn, Yinghui He, Jackson Ellard, Chang Guo and  
Yuning Li\**

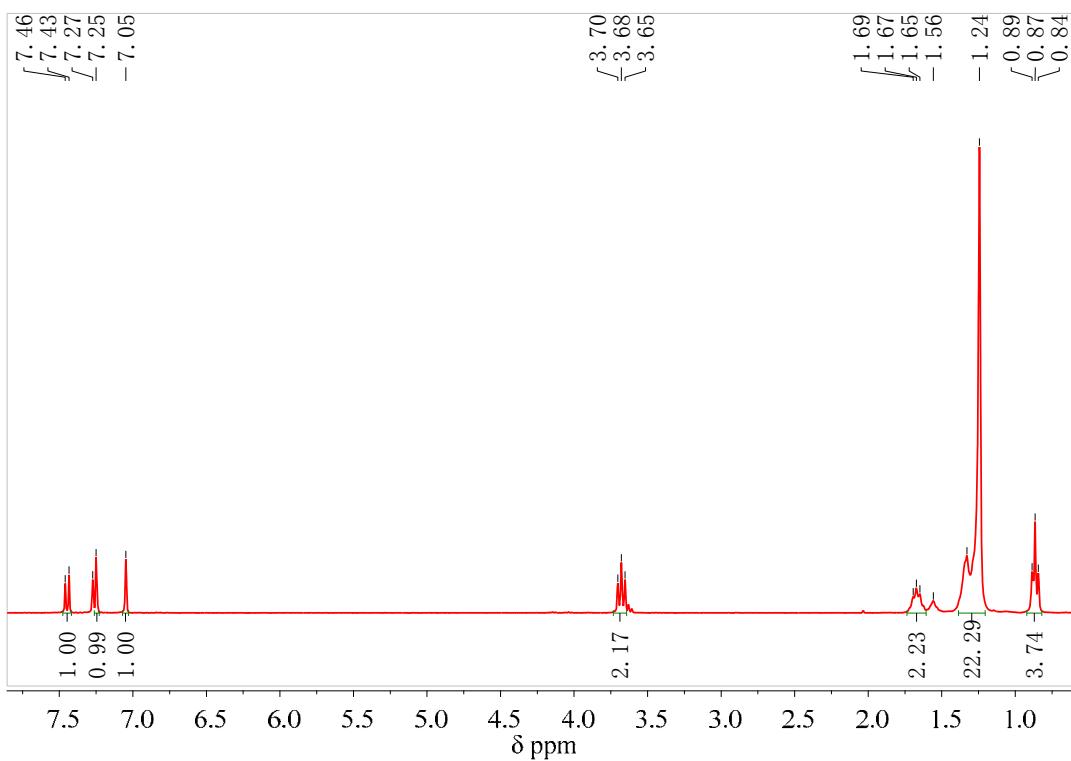
Department of Chemical Engineering and Waterloo Institute for Nanotechnology  
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3G1, Canada



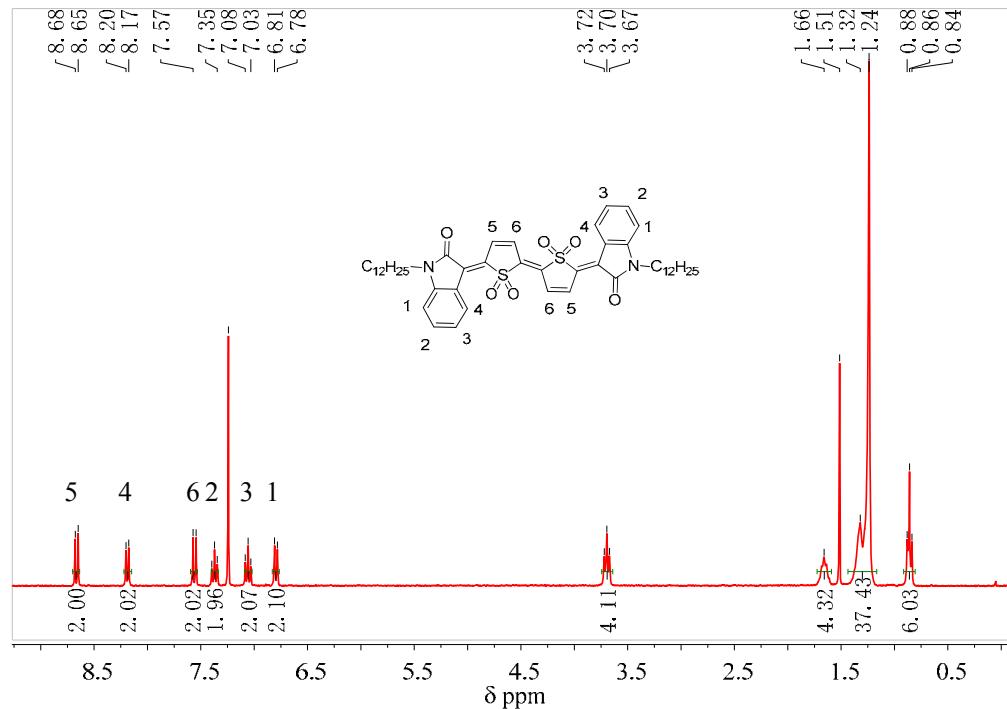
**Figure S1.**  $^1\text{H}$  NMR spectrum of **2a** measured in  $\text{CDCl}_3$ .



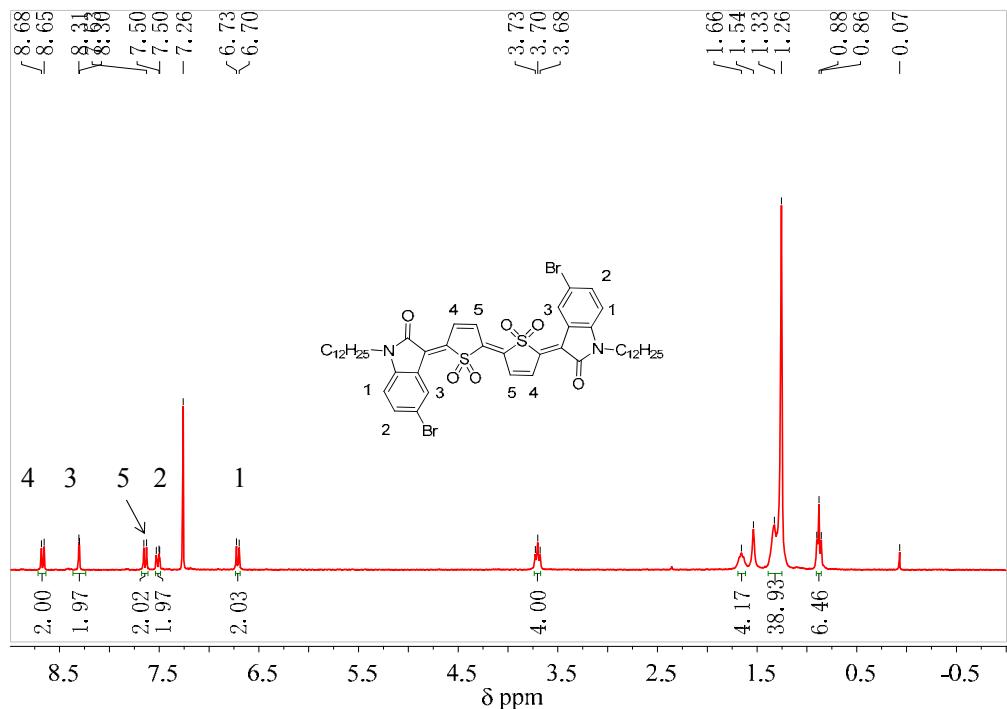
**Figure S2.**  $^1\text{H}$  NMR spectrum of **2b** measured in  $\text{CDCl}_3$ .



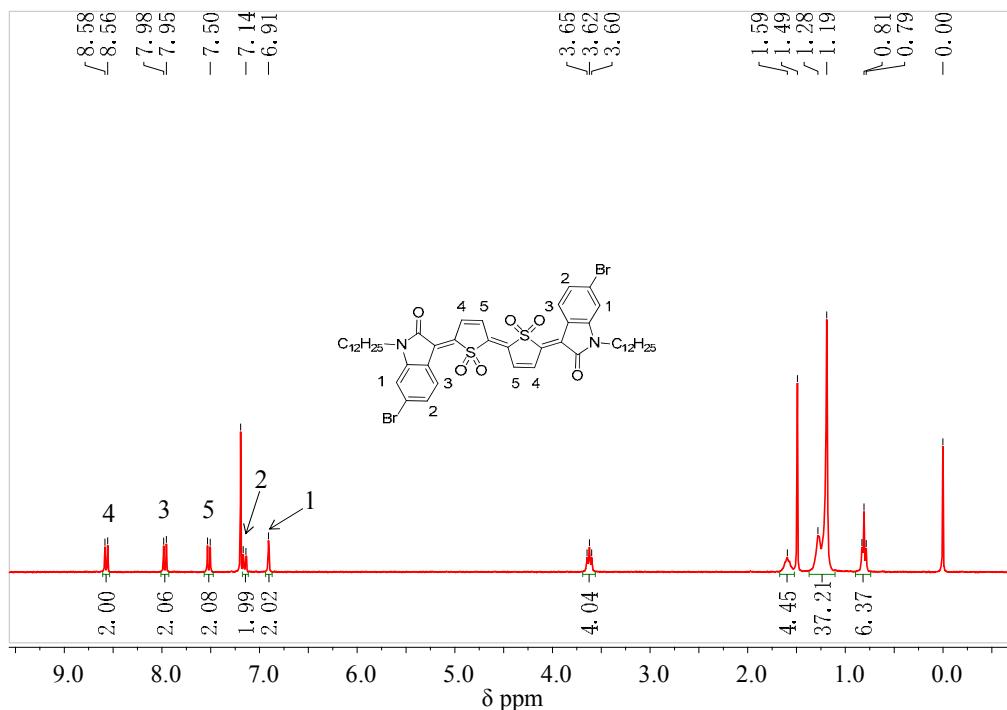
**Figure S3.**  $^1\text{H}$  NMR spectrum of **2c** measured in  $\text{CDCl}_3$ .



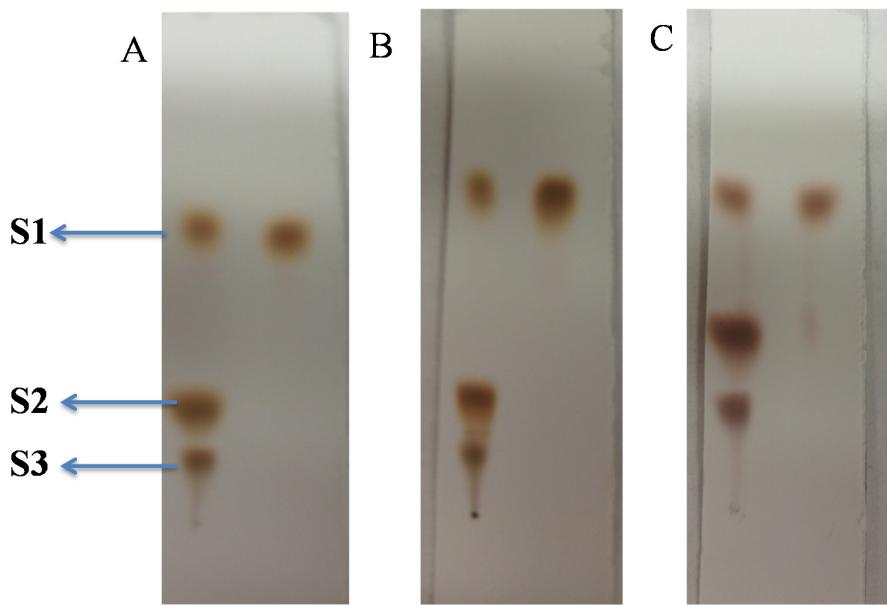
**Figure S4.**  $^1\text{H}$  NMR spectrum of **4a-S1** measured in  $\text{CDCl}_3$ .



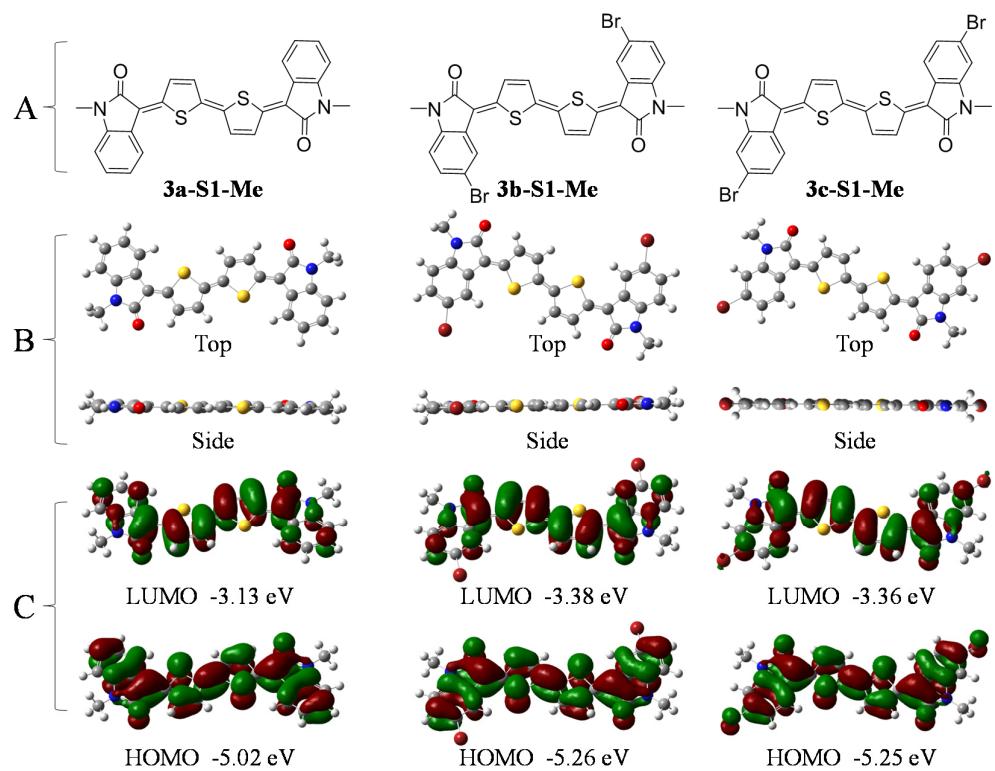
**Figure S5.**  $^1\text{H}$  NMR spectrum of **4b-S1** measured in  $\text{CDCl}_3$ .



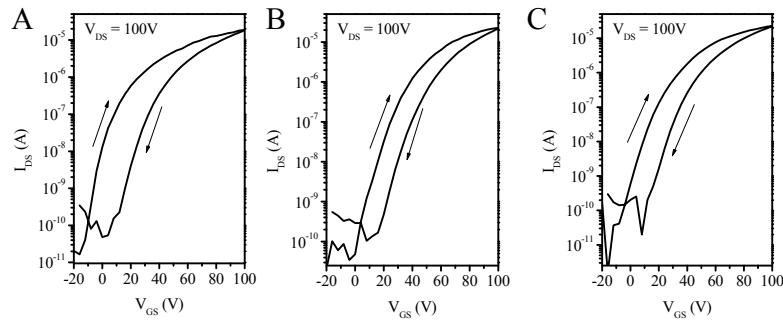
**Figure S6.**  $^1\text{H}$  NMR spectrum of **4c-S1** measured in  $\text{CDCl}_3$ .



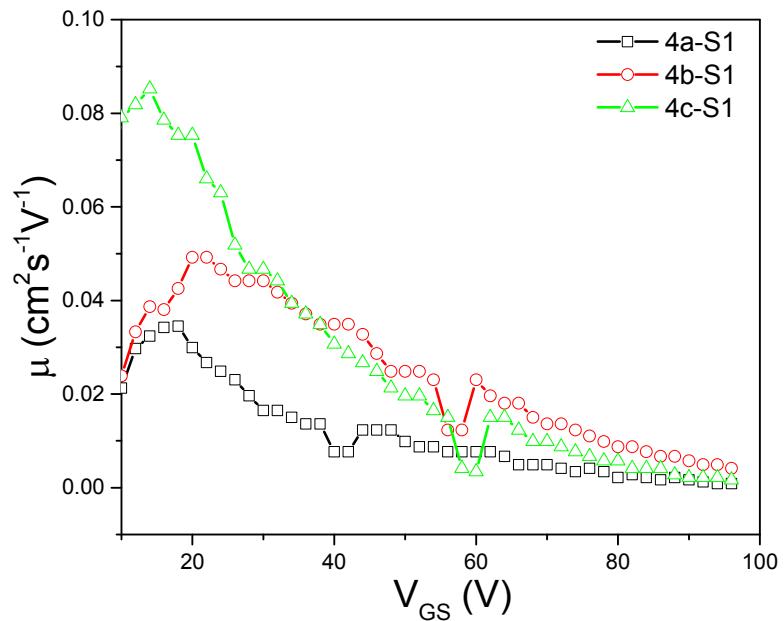
**Figure S7.** Thin layer chromatography (TLC) analysis of **4a** (A), **4b** (B) and **4c** (C) before (left: three spots) and after (right: one spot) heat treatment in refluxing toluene.



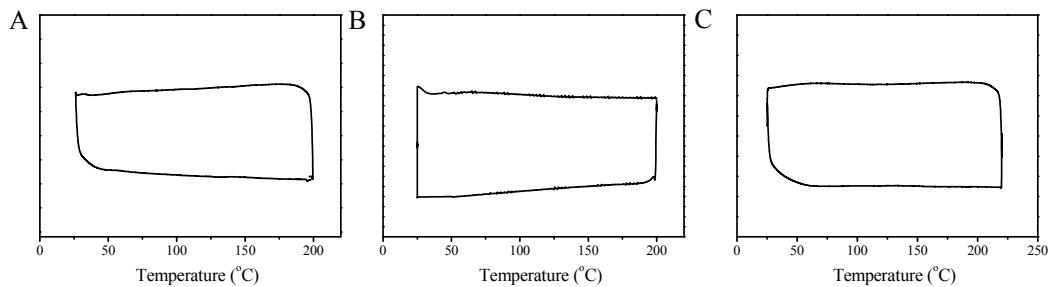
**Figure S8.** Chemical structures (A) and the DFT calculation results: optimized molecular geometries (B) and electron density distributions (C) for the indophenine model compounds **3a-S1-Me**, **3b-S1-Me** and **3c-S1-Me**.



**Figure S9.** The transfer curves of the OTFT devices based on the non-annealed **4a-S1** (A), **4b-S1** (B) and **4c-S1** (C) thin films with forward and reverse sweep gate voltages ( $V_{GS}$ ).



**Figure S10.** Mobility values of OTFT devices extracted in the saturation regimes as a function of gate bias ( $V_{DS} = 100$  V). The output and transfer curves of these devices are shown in Figure 6 in the main text.



**Figure S11.** Differential scanning calorimetry (DSC) curves of **4a-S1**, **4b-S1** and **4c-S1** in the first heating/cooling scan at a scan rate of 10 °C min<sup>-1</sup> under nitrogen.